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<i>""</i>		<u> </u>	for Imaging Applications", 1999 IEEE Ultrasonics Symposium Proceedings. International Symposium (Cat. No. 99CH 37027), 1999 IEEE Ultrasonics Symposium, Proceedings. International Symposium. Caesars Tahoe, NV, U.S.A. 17-20 Oct. 1999, Pages													
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